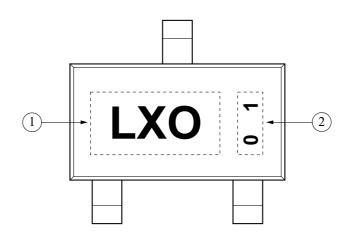


## **SEMICONDUCTOR**MARKING SPECIFICATION

## 1. Marking method

Laser Marking

## 2. Marking



No.	Item	Marking	Description
1)	Device Mark	LX	KTC3207T
	h <sub>FE</sub> Grade	О	O , Y
2	* Lot No.	01	2006. 1st Week [0:1st Character, 1:2nd Character]

Note) \* Lot No. marking method

Lot No.	Description	Remark
01, 0251, 52	01: 2006. 1st Week, 02: 2006. 2nd Week 51: 2006. 51th Week, 52: 2006. 52th Week.	Rotation for 4 years: 0152:2006, 2010, 2014 0A5B:2007, 20011, 2015 J1E2:2008, 2012, 2016 JAEB:2009, 2013, 2017
0A, 0B5A, 5B**	0A: 2007. 1st Week, 0B: 2007. 2nd Week 5A: 2007. 51th Week, 5B: 2007. 52th Week.	
J1, J2E1, E2**	J1: 2008. 1st Week, J2: 2008. 2nd Week E1: 2008. 51th Week, E2: 2008. 52th Week.	
JA, JBEA, EB**	JA: 2009. 1st Week, JB: 2009. 2nd Week EA: 2009. 51th Week, EB: 2009. 52th Week.	

<sup>\*\*:</sup> Meaning (A=1, B=2, C=3, D=4, E=5, F=6, G=7, H=8, I=9, J=0)